

Product Change Notification - LIAL-22MHLM308

Date:

03 Aug 2018

Product Category:

8-bit Microcontrollers

Affected CPNs:

7

Notification subject:

CCB 3313, 3313.001 Final Notice: Qualification of MMT as a new assembly site for selected Atmel products of the 56k and 56.8k wafer technologies available in 44L and 28L PLCC packages. **Notification text:**

PCN Status: Final notification. PCN Type: Manufacturing Change Microchip Parts Affected:

Please open one of the icons found in the Affected CPNs section above.

NOTE: For your convenience Microchip includes identical files in two formats (.pdf and .xls).

Description of Change:

Qualification of MMT as a new assembly site for selected Atmel products of the 56k and 56.8k wafer technologies available in 44L and 28L PLCC packages.

Pre Change:

Assembled in ANAP using Au wire, CRM-1076E die attach and C194 lead frame material or assembled in LPI using Au or CuPdAu wire, CRM-1033BF die attach and C151 lead frame material. **Post Change:**

Assembled in MMT using 3280 die attach and C151 lead frame material.

Pre and Post Change Summary:

Impacts to Data Sheet:

None

		Post Change								
Assembly Site	Amkor Technology Philippine (P1/P2), INC. (ANAP)	Lingsen Precision Industires, LTD. (LPI)		Industires, LTD. (LPI) Thailand (Bra						
Wire material	Au	Au	CuPdAu	Au						
Die attach material	CRM-1076E	CRM-1033BF		3280						
Molding compound material	G600	G600		G600		G600		G600		G600
Lead frame material	C194	C1	51	C151						

Change Impact:

None

Reason for Change:

To improve on-time delivery performance by qualifying MMT as a new assembly site **Change Implementation Status:**

In Progress



Estimated First Ship Date:

September 03, 2018 (date code: 1836)

NOTE: Please be advised that after the estimated first ship date customers may receive pre and post change parts.

Time Table Summary:

	April 2018			August 2018				September 2018						
Workweek	14	15	16	17	18	31	32	33	34	35	36	37	38	39
Initial PCN Issue Date		Х												
Qual Report Availability						Х								
Final PCN Issue Date						Х								
Estimated											V			
Implementation Date											^			

Method to Identify Change:

Traceability code

Qualification Report:

Please open the attachments included with this PCN labeled as PCN_#_Qual Report.

Revision History:

April 03, 2018: Issued initial notification.

August 03, 2018: Issued final notification. Revised the subject and description to add the 56k wafer technology based on the scope. Attached the qualification report and provided estimated first ship date to be on September 03, 2018.

The change described in this PCN does not alter Microchip's current regulatory compliance regarding the material content of the applicable products.

Attachment(s):

PCN LIAL-22MHLM308 Qual Report.pdf

Please contact your local <u>Microchip sales office</u> with questions or concerns regarding this notification.

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LIAL-22MHLM308 - CCB 3313, 3313.001 Final Notice: Qualification of MMT as a new assembly site for selected Atmel products of the 56k and 56.8k wafer technologies available in 44L and 28L PLCC packages.

Affected Catalog Part Numbers (CPN)

AT80C51RD2-SLRUM AT80C51RD2-SLSUM AT89C5115-SISUM AT89C51AC2-SLSUM AT89C51AC3-SLSUM AT89C51CC01CA-SLSUM AT89C51CC01UA-SLSUM AT89C51CC02CA-SISUM AT89C51CC02UA-SISUM AT89C51CC03CA-SLRUM AT89C51CC03CA-SLSUM AT89C51CC03UA-SLSUM AT89C51ED2-SLRUM AT89C51ED2-SLSUM AT89C51IC2-SLRUL AT89C51IC2-SLRUM AT89C51IC2-SLSUL AT89C51IC2-SLSUM AT89C51ID2-SLRUM AT89C51ID2-SLSUM AT89C51RB2-SLRUL AT89C51RB2-SLRUM AT89C51RB2-SLSUL AT89C51RB2-SLSUM AT89C51RC2EDR-SLRUM AT89C51RC2-SLRUL AT89C51RC2-SLRUM AT89C51RC2-SLSUL AT89C51RC2-SLSUM AT89C51RD2-SLRUM AT89C51RD2-SLSUM AT89C51RD2-SLSUMA0



QUALIFICATION REPORT SUMMARY RELIABILITY LABORATORY

PCN #: LIAL-22MHLM308

Date: July 14, 2018

Qualification of MMT as a new assembly site for selected Atmel products of 56.8k wafer technology available in 44L PLCC package. The selected products available in 28L PLCC package will qualify by similarity (QBS).



Purpose: Qualification of MMT as a new assembly site for selected Atmel products of 56.8k wafer technology available in 44L PLCC package. The selected products available in 28L PLCC package will qualify by similarity (QBS).

	CN	ES184281-25337				
Misc.	Assembly site	MMT				
	BD Number	BDM-001730 rev. A				
	MP Code (MPC)	568TL7T2XC01				
	Part Number (CPN)	AT89C51AC3-SLSUM				
	Paddle size	230x230				
	Material	CDA151				
	Surface	Ag Spot plated				
	Treatment	None				
Lead-Frame	Process	Stamped				
	Lead-lock	No				
	Part Number	10104409				
	Lead Plating	Matte Tin				
Bond Wire	Material	Au				
Die Attach	Part Number	3280				
Die Allach	Conductive	Yes				
МС	Part Number	G600V				
	PKG Type	PLCC				
PKG	Pin/Ball Count	44				
	Die Thickness	15 mils				
Die	Die Size	178.0x124.0 mils				
	Fab Process (site)	56.8K/MCSO				
MSL Classification		L1/245C				

CCB No.: 3313 and 3313.001



Manufacturing Information

Assembly Lot No.	Wafer Lot No.	Date Code		
MMT-190100732.000	MCSO518528359.000	18147BA		
MMT-190100733.000	MCSO518528359.000	18147BB		
MMT-190101471.000	MCSO518528359.000	1814BRY		

Result

X Pass

44L PLCC package for wafer mask 568TL assembled at MMT using Au wire is qualified at Moisture/ Reflow Sensitivity Classification Level 1 per IPC/JEDEC J-STD-020D standard. No delamination were observed on all the units.

Fail

PACKAGE QUALIFICATION REPORT									
Test Number (Reference)	Test Condition	Standard/ Method	Qty. (Acc.)	Def/SS	Result	Remarks			
Precondition Prior Perform Reliability Tests (At MSL Level 1)	Electrical Test: +90°C Ohr CSAM	JESD22- A113	900(0)	0/900 0/135	Passed	Good Devices			
	Bake 150°C, 24 hrs System: HERAEUS		900						
	85°C/85%RH Moisture Soak 168 hrs. System: Climats Excal 5423-HE	IPC/JEDE C J-STD- 020D	900						
	3x Convection-Reflow 245°C max System: Mancorp CR.5000F	020D	900						
	Post CSAM			0/135	Passed				
	Electrical Test: +90°C			0/900	Passed				
	Stress Condition: (Standard) 65°C to +150°C, 500 Cycles System: VOTSCH VT 7012 S2	JESD22- A104	252			Parts had been pre- conditione at 245°C			
	Electrical Test: +90°C		252(0)	0/252	Passed				
	System: Maverick Tester								
Temp Cycle	Bond Strength:								
	Wire Pull (> 6.00 grams)		15(0)	0/15	Passed				
	Bond Shear (>22.00 grams)								
	Stress Condition: (Standard) +130°C/85%RH, 96 hrs. System: HIRAYAMA HASTEST PC-422R8	JESD22- A118	254			Parts had been pre- conditione at 245°C			
UNBIASED- HAST	Electrical Test: +90°C System: Maverick Tester		254(0)	0/254	Passed				

	PACKAGE QUALIFICATION REPORT								
Test Number (Reference)	Test Condition	Standard/ Method	Qty. (Acc.)	Def/SS.	Result	Remarks			
HAST	Stress Condition: (Standard) +130°C/85%RH, 96 hrs. Bias Volt: 5.5 Volts System: HIRAYAMA HASTEST PC-422R8	JESD22- A110	252			Parts had been pre- conditioned at 245°C			
	Electrical Test: +90°C System: Maverick Tester		252(0)	0/252	Passed				
lish Tomoordur	Stress Condition: Bake 175°C, 504 hrs System: HERAEUS	JESD22- A103	50			50 units			
High Temperature Storage Life	Electrical Test :+90°C		50(0)	0/50	Pass				
Solderability Temp 245°C	Bake: Temp 155°C,4Hrs System: Oven Solder Bath: Temp.245°C Solder material: SnPb	J-STD-002	15 (0)	0/15	Pass	Performed at MPHIL			
	Visual Inspection: External Visual Inspection								
Physical Dimensions	Physical Dimension, 10 units from 3 lot	JESD22- B100/B108	30(0) Units	0/30	Pass				
Bond Strength Data Assembly	Wire Pull (> 6.00 grams)	M2011.8 MIL-STD- 883	30(0) Wires	0/30	Pass				
	Bond Shear (>22.00 grams)	M2011.8 MIL-STD- 883	30(0) bonds	0/30	Pass				